



T. M. Skiff

1765

Patent

Attorney's Docket No. 015290-465

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Robert J. O'DONNELL et al.) Group Art Unit: 1765
Application No.: 09/749,921) Examiner: B. X. Tran
Filed: December 29, 2000) Confirmation No.: 6804
For: CORROSION RESISTANT)
COMPONENT OF SEMICONDUCTOR)
PROCESSING EQUIPMENT AND)
METHOD OF MANUFACTURE)
THEREOF)

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the restriction requirement set forth in the Official Action dated September 23, 2003, Applicants hereby elect, with traverse, the invention covered by Group II, Claims 8-18.

Early and favorable consideration on the merits is respectfully requested.

Respectfully submitted,

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Date: September 30, 2003

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